



1763

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No. 239/166

In re patent application of

Seung-un KIM et al.

Group Art Unit: 1763

Serial No. 10/084,198

Examiner: S. Macarthur

Filed: February 28, 2002

For: APPARATUS AND METHOD FOR SUPPLYING CHEMICALS IN CHEMICAL  
MECHANICAL POLISHING SYSTEMS

**RESPONSE TO RESTRICTION REQUIREMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA. 22313-1450

Sir:

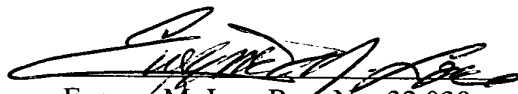
In response to the Office Action dated September 16, 2003, applicants hereby elect the claims of Group I, claims 1-15, for prosecution in the subject application.

Applicants, of course, reserve the right to file a divisional application covering the subject matter of the non-elected claims.

Receipt of the initial Office Action on the merits is awaited.

Respectfully submitted,

Date: October 15, 2003

  
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PETITION and  
DEPOSIT ACCOUNT CHARGE AUTHORIZATION

This document and any concurrently filed papers are believed to be timely. Should any extension of the term be required, applicant hereby petitions the Director for such extension and requests that any applicable petition fee be charged to Deposit Account No. 50-1645.

If fee payment is enclosed, this amount is believed to be correct. However, the Director is hereby authorized to charge any deficiency or credit any overpayment to Deposit Account No. 50-1645.

Any additional fee(s) necessary to effect the proper and timely filing of the accompanying-papers may also be charged to Deposit Account No. 50-1645.